



PATENT
8017-1094

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Toshiji TAIJI et al.

Conf. 2404

Application No. 10/616,914

Group 1765

Filed July 11, 2003

Examiner L. Umez Eronini

SLURRY FOR CHEMICAL MECHANICAL POLISHING

AMENDMENT

Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

May 11, 2006

Sir:

Responsive to the Official Action of January 11, 2006,
it is respectfully requested that the above-identified
application be amended as follows:

Amendments to the Claims are reflected in the listing
of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.